

Attorney Docket # 5367-226RCE

MS-AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Werner PLASS et al.

Serial No.: 10/631,384

Filed: July 31, 2003

For: Surface Emitting Semiconductor Laser Chip and  
Method for Producing the Chip

Examiner: SEFER, Ahmed N.  
Group Art: 2826

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

February 23, 2007  
(Date of Deposit)

Alfred W. Froeblich  
Name of applicant, assignee or Registered Representative

Signature

February 23, 2007  
Date of Signature

Mail Stop: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

PETITION

Applicants hereby petition for a one-month extension of the original shortened statutory response period set in the Office Action of October 23, 2006. A check in the amount of \$120 in payment of the government fee for a one-month extension of time is enclosed herewith so that the period for response is extended to February 23, 2007. Any additional fees or charges required at this time in connection with the present application may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

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## **RESPONSE**

In response to the Final Office Action dated October 23, 2006, please amend the above-identified application as follows:

**Amendments to the Drawings** begin on page 4 of this paper.

**Amendments to the Claims** begin on page 5 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.